

AMENDMENTS TO THE SPECIFICATION:

Page 13, replace the paragraph beginning on line 18 with the following amended paragraph:

--Figs. 7a to 7c are sectional views each taken along the line ~~A-A'~~ 7-7 schematically showing the process for manufacturing the transistors in active matrix substrate in the reflection type liquid crystal display device of the embodiment 1 of the present invention,--

Page 13, replace the paragraph beginning on line 22 with the following amended paragraph:

--Figs. 8a to 8e are sectional views each taken along the line ~~B-B'~~ 8-8 schematically showing the process for manufacturing the storage capacitor of the active matrix substrate in the reflection type liquid crystal display device of the embodiment 1 of the present invention,--